



**ELECTRONIC COPY**

## LABORATORY GROWN DIAMOND REPORT

October 3, 2024	
IGI Report Number	LG656477958
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	CUT CORNERED RECTANGULAR MODIFIED BRILLIANT
Measurements	9.91 X 7.33 X 4.88 MM

## GRADING RESULTS

Carat Weight	3.05 CARATS
Color Grade	D
Clarity Grade	VS 2

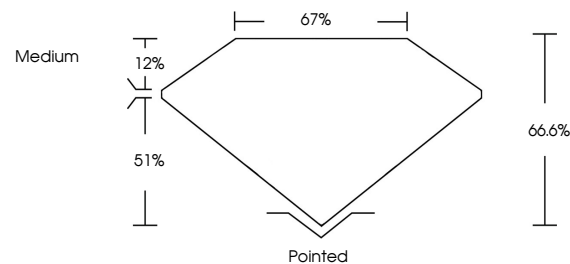
### ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	 LG656477958

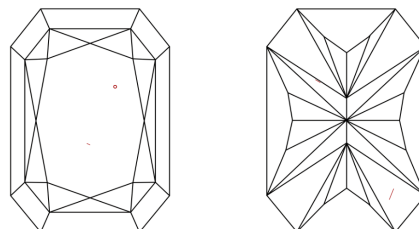
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa

LG656477958  
Report verification at [igi.org](https://www.igi.org)

## PROPORTIONS



## CLARITY CHARACTERISTICS



## KEY TO SYMBOLS

Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.



Sample Image Used

**COLOR**

D E F G H I J Faint Very Light Light

## CLARITY

IF	VVS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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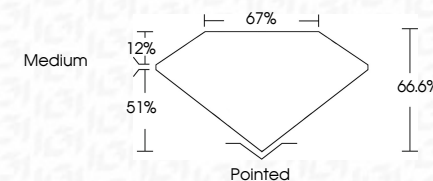
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October 3, 2024	GI Report No LG6&477968	3.05 CARATS	D
CU CUT CORNERED RECT. MODIFIED BRILLIANT			
9.91 X 7.33 X 4.88 MM		VS 2	
Carat Weight	Color Grade	66.6%	57%
Clarity Grade	Depth	Medium	
Table	Girdle		
Culet			
Polish			
Symmetry			
Fluorescence			
Comments			

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(CVD) growth process.